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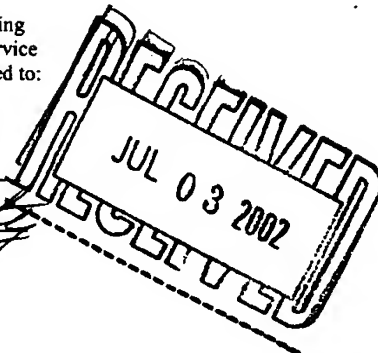
Barbara Haggerty

Name

Signature

May 31, 2002

Date of Signature



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Of: Leising et al.

Serial No.: 10/004,995

Filed: December 5, 2001

For: Preparation Of  $\epsilon$ -Phase Silver Vanadium Oxide From  
 $\gamma$ -Phase SVO Starting Material

Examiner: Unknown

Art Unit: 1745

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ORIGINALLY FILEDSUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT  
Pursuant to 37 CFR 1.56

1. Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

IDS For: Preparation Of  $\epsilon$ -Phase Silver Vanadium  
Oxide From  $\gamma$ -Phase SVO Starting Material  
Inventor: Leising et al.  
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The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has been made (37 CFR 1.56(g)), an admission that the information cited is, or is considered to be material to patentability or that no other material information exists.

The filing of this IDS shall not be construed as an admission against interest in any manner (Notice of Jan. 9, 1992, 1135 O.G. 13-25, at 25).

2. Attached is Form PTO-1449. Legible copies of all items listed accompany this IDS.
3. No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, or to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the statement.

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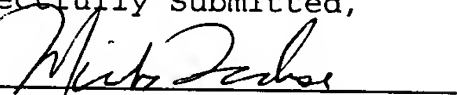
Inventor: Leising et al.

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below, who makes this statement on information supplied by the  
inventors and on information in the agent's file.

Respectfully Submitted,

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May 31, 2002